

### REMARKS

Claims 1-32 are pending in the application, with claims 1-6 being independent.

Applicant acknowledges with appreciation the Examiner's indication that claims 2, 4, 8, 10, 13-30 and 32 are directed to allowable subject matter.

Claims 1-6 have been amended in response to the Examiner's objections as to the clarity of those claims. The amendments are believed to address the Examiner's concerns.

Claims 1, 3, 5-7, 9, 11, 12 and 31 have been rejected as being anticipated by Ohtani. Applicant requests reconsideration and withdrawal of this rejection at least because Ohtani does not describe or suggest "forming an electrode made of the first conductive film by etching the first conductive film by self-alignment using the electrode made of the second conductive film as a mask after forming the electrode made of the second conductive film," as recited in each of amended independent claims 1, 3 and 5, or "etching the first conductive film to form a patterned first conductive film by self-alignment using ~~the electrode made of the second conductive film~~ the patterned second conductive film as a mask after etching the second conductive film," as recited in amended independent claim 6.

Ohtani, in Figs. 3A-4C, appears to indicate that the electrode (211b) made of the second conductive film and the electrode (211a) made of the first conductive film are formed simultaneously. As such, Ohtani does not disclose that the electrode made of the first conductive film is formed after the electrode made of the second conductive film is formed. Accordingly, the rejection should be withdrawn for at least this reason.

Finally, in response to the Examiner's objection to claims 3, 5 and 6 as being substantial duplicates of claim 1, claim 3 has been amended to recite "a p-type impurity" instead of "an n-type impurity," and claim 5 has been amended so as to recite "an impurity." With respect to claim 6, applicant submits that claim 6 is not a duplicate of claim 1. For example, claim 1 recites "forming an electrode made of the second conductive film by etching the second conductive film" while claim 6 recites "etching the second conductive film to form a patterned second conductive film."

Applicant : Shunpei YAMAZAKI et al.  
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Page : 11 of 11

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Respectfully submitted,

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John F. Hayden  
Reg. No. 37,640

Fish & Richardson P.C.  
1425 K Street, N.W.  
11th Floor  
Washington, DC 20005-3500  
Telephone: (202) 783-5070  
Facsimile: (202) 783-2331